<u> </u>	Application No.	Applicant(s)
Notice of Allowability	09/942,014	DEWA, ANDREW S.
	Examiner	Art Unit
	Lan Vinh	1765
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG	(OR REMAINS) CLOSED or other appropriate comm GHTS. This application is and MPEP 1308.	in this application. If not included
<ol> <li>This communication is responsive to <u>Amendment and remains</u></li> <li>The allowed claim(s) is/are <u>1-18</u>.</li> </ol>	arks tiled on 8///2003.	
3. The drawings filed on are accepted by the Examiner		
4. ☐ Acknowledgment is made of a claim for foreign priority una  a) ☐ All b) ☐ Some* c) ☐ None of the:	der 35 U.S.C. § 119(a)-(d)	or (f).
<ol> <li>Certified copies of the priority documents have</li> </ol>	been received.	
2.  Certified copies of the priority documents have	been received in Applicati	on No
<ol> <li>Copies of the certified copies of the priority doc International Bureau (PCT Rule 17.2(a)).</li> </ol>	uments have been receive	ed in this national stage application from the
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority un reference was included in the first sentence of the specifical	tion or in an Application Da	ata Sheet. 37 CFR 1.78.
(a) ☐ The translation of the foreign language provisional ap	oplication has been receive	ed.
<ol> <li>Acknowledgment is made of a claim for domestic priority un in the first sentence of the specification or in an Application</li> </ol>	der 35 U.S.C. §§ 120 and/ Data Sheet. 37 CFR 1.78.	or 121 since a specific reference was included
Applicant has THREE MONTHS FROM THE "MAILING DATE" of the below. Failure to timely comply will result in ABANDONMENT of the below.	this communication to file and its application. THIS THE	a reply complying with the requirements noted REE-MONTH PERIOD IS NOT EXTENDABLE
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which gives</li> </ol>	s reason(s) why the oath o	AMINER'S AMENDMENT or NOTICE OF r declaration is deficient.
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must</li> <li>(a) ☐ including changes required by the Notice of Draftsperso</li> <li>1) ☐ hereto or 2) ☐ to Paper No</li> </ol>	be submitted. on's Patent Drawing Review	w ( PTO-948) attached
(b) $\square$ including changes required by the proposed drawing co	rrection filed, whic	h has been approved by the Examiner.
(c) ☐ including changes required by the attached Examiner's	Amendment / Comment o	r in the Office action of Paper No
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the	4(c)) should be written on the e margin according to 37 CF	he drawings in the front (not the back) of FR 1.121(d).
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposi attached Examiner's comment regarding REQUIREMENT FOR TH</li> </ol>	it of BIOLOGICAL MAT! IE DEPOSIT OF BIOLOGI	ERIAL must be submitted. Note the CAL MATERIAL.
Attachment(s)		
1☐ Notice of References Cited (PTO-892)	5∏ Notice of Info	ormal Patent Application (PTO-152)
2⊠ Notice of Draftperson's Patent Drawing Review (PTO-948)	6∐ Interview Sui	mmary (PTO-413), Paper No
B Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No		Amendment/Comment
4 Examiner's Comment Regarding Requirement for Deposit of Biological Material		Statement of Reasons for Allowance
		Lan Vinh AU 1765

U.S. Patent and Trademark Office PTOL-37 (Rev. 11-03) Application/Control Number: 09/942,014

Art Unit: 1765

## Allowable Subject Matter

Claims 1-18 are allowed.

The following is an examiner's statement of reasons for allowance:

Regarding claims 1, 11, the applicants have presented persuasive arguments (page 7-8 of Applicants remarks filed on 8/7/2003) that the cited prior art of record fails to disclose the step of temporarily mounting a structure wafer to a carrier wafer with alignment relative to the plurality of holes in the carrier wafer. The closest cited prior art of Neukerman et al (US 6,445,844) discloses the step of connecting/mounting a structure wafer 162 to a substrate/carrier 212 with alignment relative to the plurality of holes in the substrate 212 without removing the wafer 162 from the substrate 212 (fig. 16b, fig. 16d). The reasons for allowance of claims 7, 17 have been stated in the previous office action (paper 3)

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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## Conclusion

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lan Vinh whose telephone number is 703 305-6302. The examiner can normally be reached on M-F 8:30-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 703 305-2667. The fax phone number for the organization where this application or proceeding is assigned is 703 872-9310.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 308-0661.

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November 26, 2003